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Patent Application  
ATM-515 (7486)IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:	) Docket No.: ATM-515 (7486)
Applicant: XU, Chongying, et al.	) Examiner: Virginia MANOHARAN
Application No.: 10/015,326	) Art Group: 1764
Date Filed: December 13, 2001	) Confirm. No.: 2946
Title: METHOD FOR REMOVAL OF IMPURITIES IN CYCLIC SILOXANES USEFUL AS PRECURSORS FOR LOW DIELECTRIC CONSTANT THIN FILMS	) Customer No.:  25559


FACSIMILE TRANSMISSION CERTIFICATE  
ATTN: Examiner Virginia MANOHARAN

Fax No.: (703) 872-9306

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on February 28, 2005, to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

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Yongzhi Yang

February 28, 2005

Date

RESPONSE TO NOVEMBER 26, 2004 OFFICE ACTION  
IN UNITED STATES PATENT APPLICATION NO. 10/015,326

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This responds to the November 26, 2004 Office Action in the above-identified application. Please amend the claims of the application as set out in the following Section I (Amendments to the Claims). Remarks addressing various issues raised in the November 26, 2004 Office Action are set out in Section II (Remarks) hereof.

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